RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITING PROCEDURE EXAMINING GROUP 2800**

Slater & Matsil, L.L.P.

Suite 1000 17950 Preston Road Dallas, Texas 75252-5793

Phone: 972-732-1001 Facsimile: 972-732-9218

RECEIVED CENTRAL FAX CENTER

AUG 2 5 2005

FACSIMILE COVER SHEET

To Examiner: Hung K. Vu

Total Pages Sent:

6

Technology Center 2800

(including cover sheet)

Facsimile Number: (571) 273-8300

Transmission Date:

August 25, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Buerke, et al.

Docket No.:

INF-118

Serial No.:

10/724,136

Art Unit:

2811

Date Filed:

December 1, 2003

TITLE:

Low Resistance Barrier For A Microelectronic Component And Method For

Fabricating The Same

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to Mail Stop AF at the U.S. Patent and Trademark Office at (571) 273-8300 on August 25, 2005:

- Certification of Facsimile Transmission (1 page)
- Amendment (5 pages)

Respectfully submitted,

ristiz Enzeldat C

Kristy Engeldahl Legal Assistant

Confirmation Respectfully Requested

RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITING PROCEDURE EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
CENTRAL FAX CENTER

Applicant:

Buerke, et al.

Docket No.:

INF-118

AUG 2 5 2005

Serial No.:

10/724,136

Art Unit:

2811

Filed:

December 1, 2003

Examiner:

Hung K. Vu

For:

Low Resistance Barrier For A Microelectronic Component And Method For

Fabricating The Same

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Final Office Action mailed June 30, 2005. Please amend the above-referenced application as follows.